

ILC-HiGrade Scientific and Annual Meeting

(CERN, 25 February, 2010)

Mickaël LACROIX (LAL)

ILC HiGrade WP7 couplers



Summary

- ILC HiGrade base line strategy
- XFEL Coupler Design
- XFEL Coupler production
 - Sub-contractor: Fabrication/Cleaning & pre-assembly
 - LAL: Baking/Conditioning/Disassembly
- ILC Higrade schedule scenarios
- ILC Higrade cost scenarios

Summary

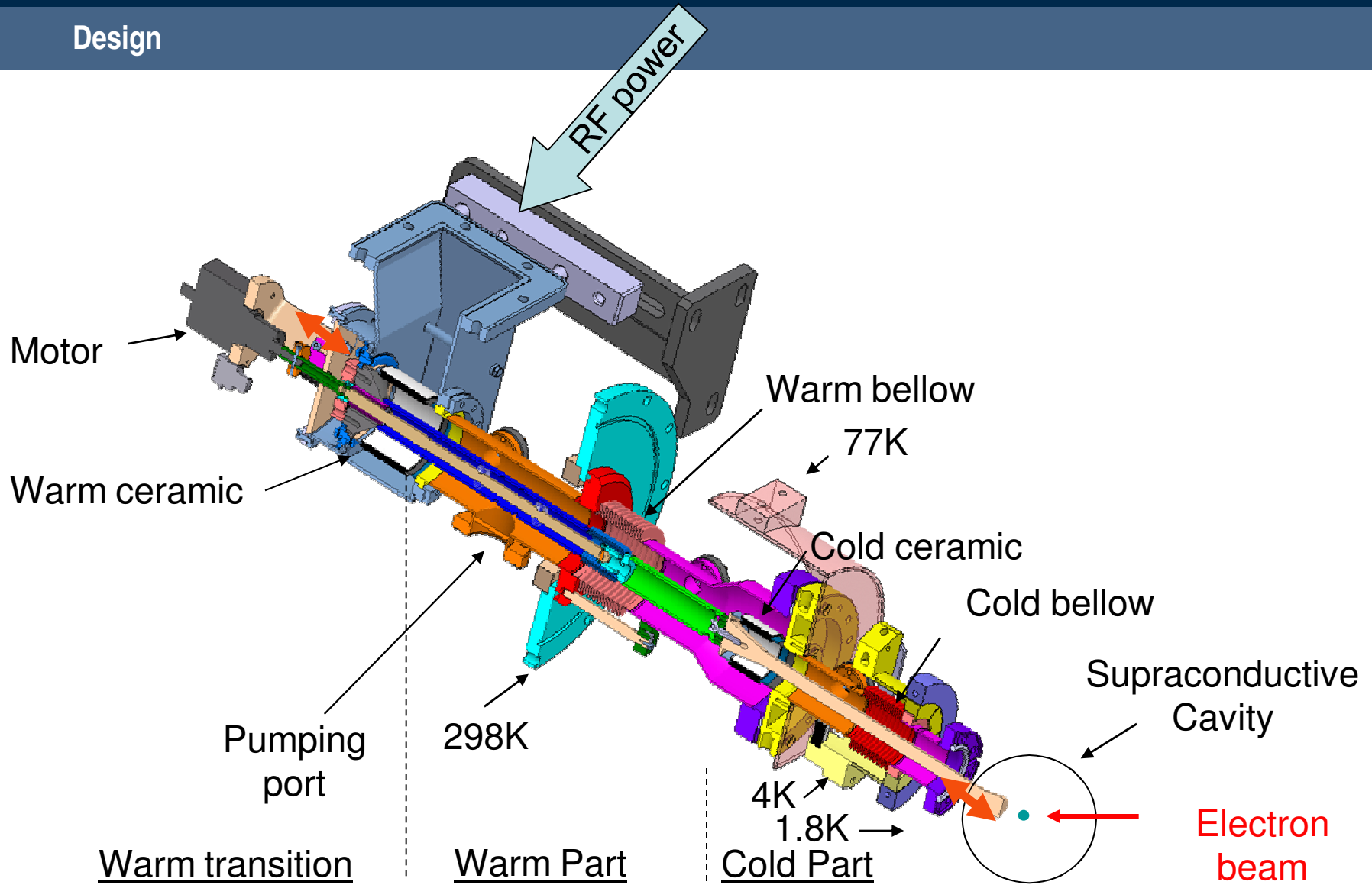
- ILC HiGrade base line strategy
 - XFEL Coupler Design
 - XFEL Coupler production
 - Sub-contractor: Fabrication
 - LAL: Baking/Conditioning
 - ILC Higrade schedule scenarios
 - ILC Higrade cost scenarios
- Add the ILC HiGrade coupler order to the XFEL order.*
- The goal is to get:*
- a reliable design (an updated TTF3 design)
 - full prepared couplers (cleaned & conditioned)
 - the large XFEL production follow up
 - a mass production cost!!!

Summary

- ILC HiGrade base line strategy
- XFEL Coupler Design
- XFEL Coupler production
 - Sub-contractor: Fabrication/Cleaning & pre-assembly
 - LAL: Baking/Conditioning/Disassembly
- ILC Higrade schedule scenarios
- ILC Higrade cost scenarios

ILC HiGrade WP7 couplers

Design



ILC HiGrade WP7 couplers

Design

Baseline

TTF3

Laboratory Studies

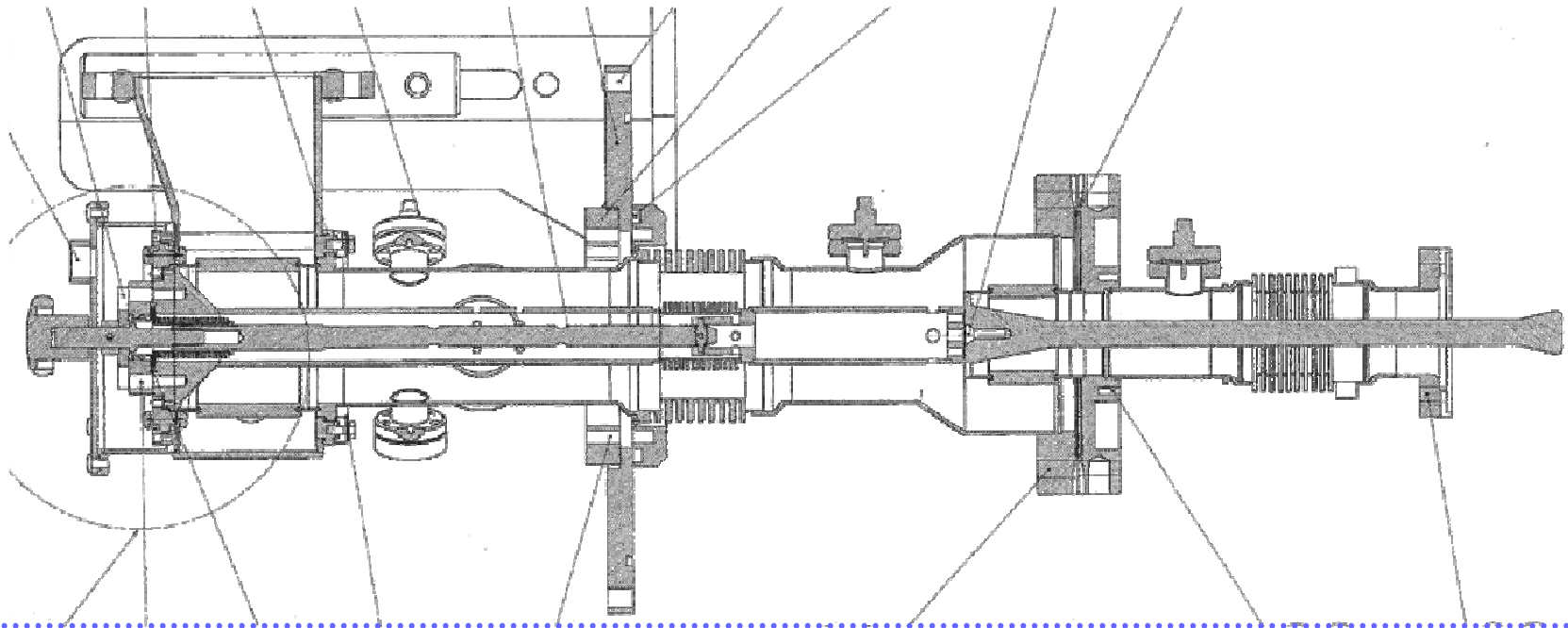
Design & tests

Manufacturer design studies

Accel
prototype for
XFEL

Toshiba
prototype for
XFEL

E2V Prototype
for XFEL



ILC HiGrade WP7 couplers

Design

Baseline

TTF3

Laboratory Studies

Design & tests

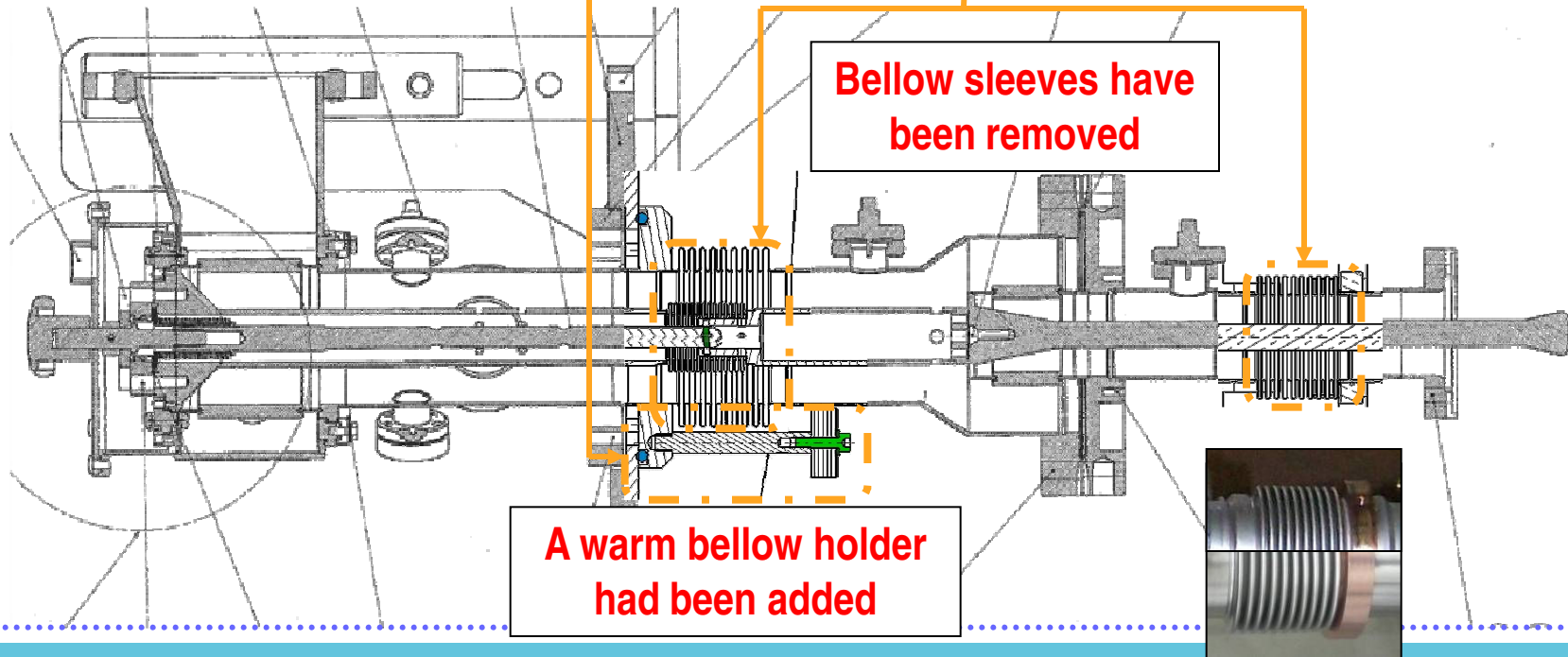
Manufacturer design studies

Accel
prototype for
XFEL

Toshiba
prototype for
XFEL

E2V Prototype
for XFEL

No prototype delivered



ILC HiGrade WP7 couplers

Design

Baseline

TTF3

Laboratory Studies

Design & tests

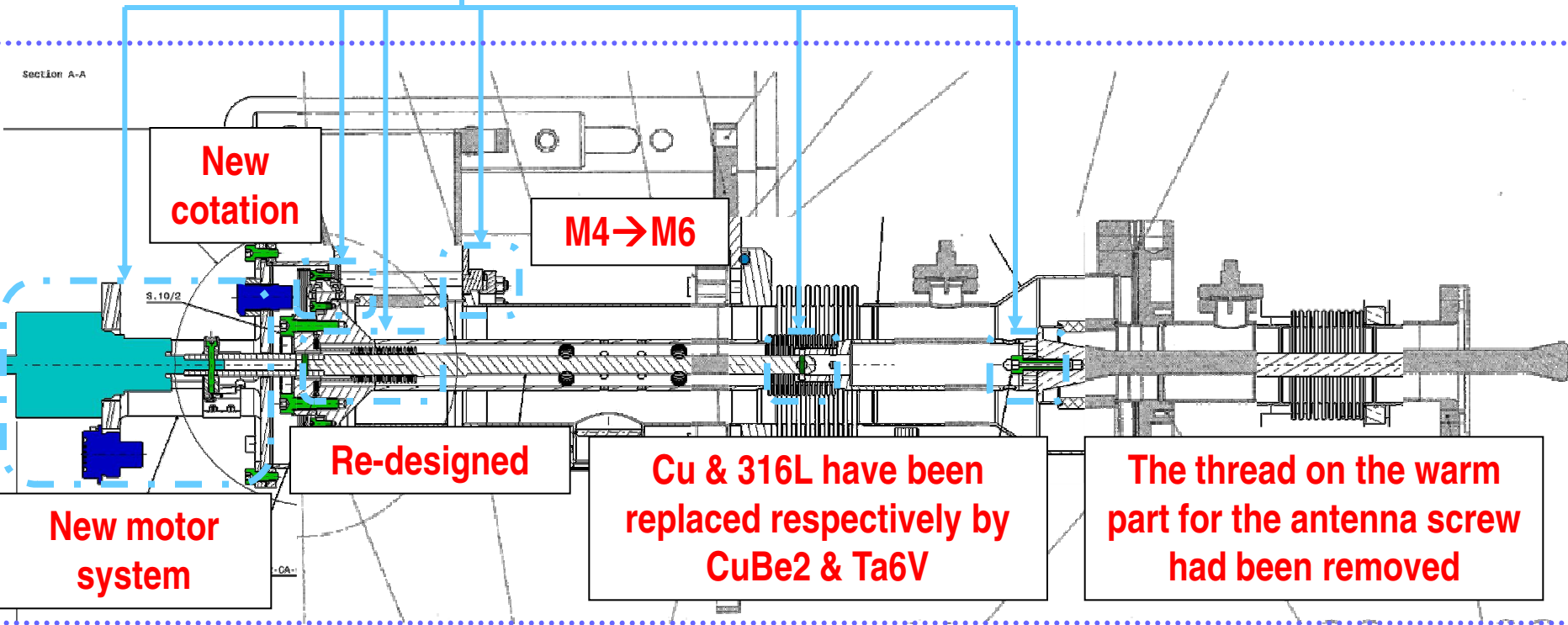
Manufacturer design studies

Accel
prototype for
XFEL

Toshiba
prototype for
XFEL

E2V Prototype
for XFEL

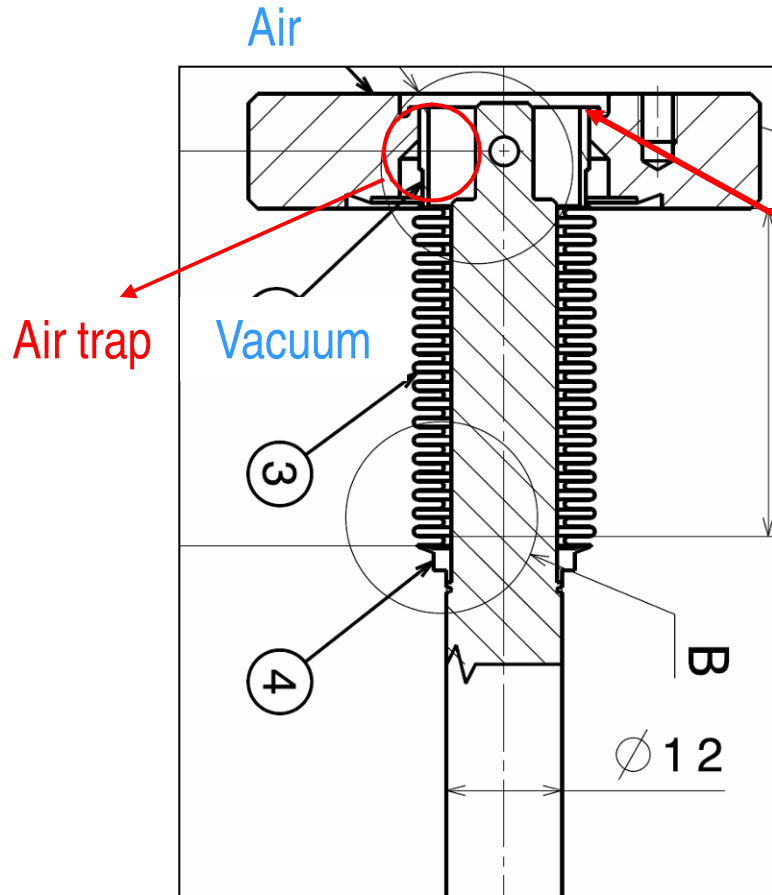
No prototype delivered



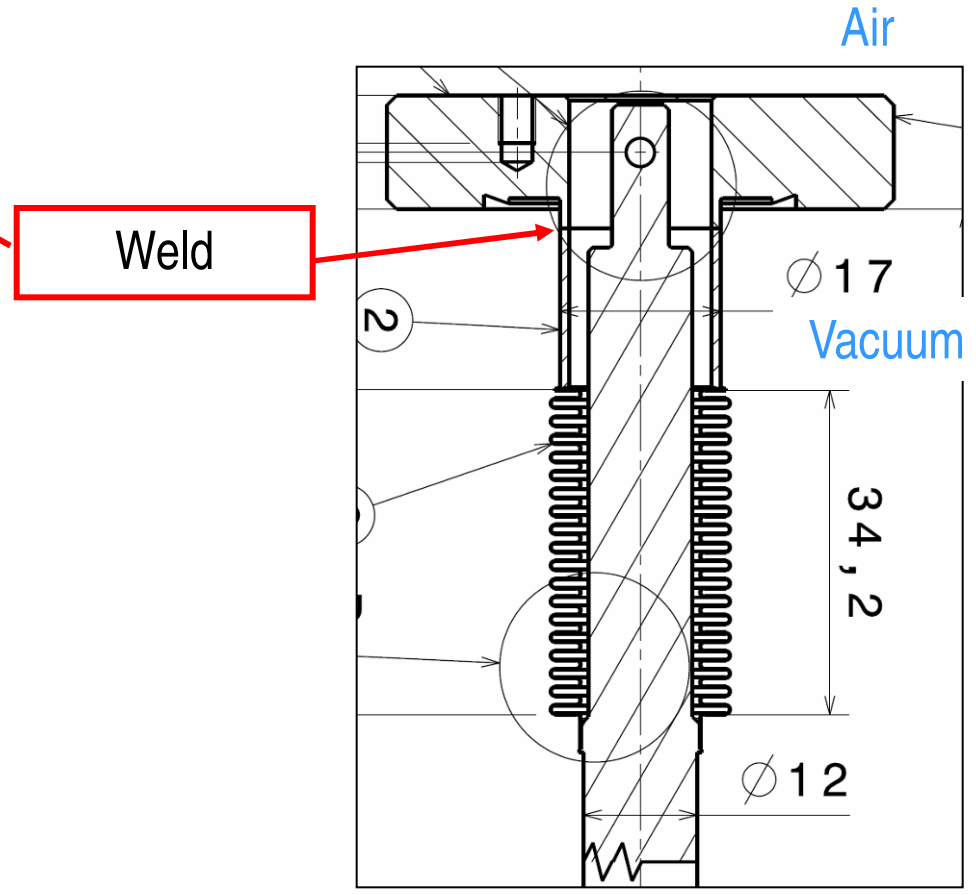
ILC HiGrade WP7 couplers

Design example

Improvement of the push-rod design



TTF3 design



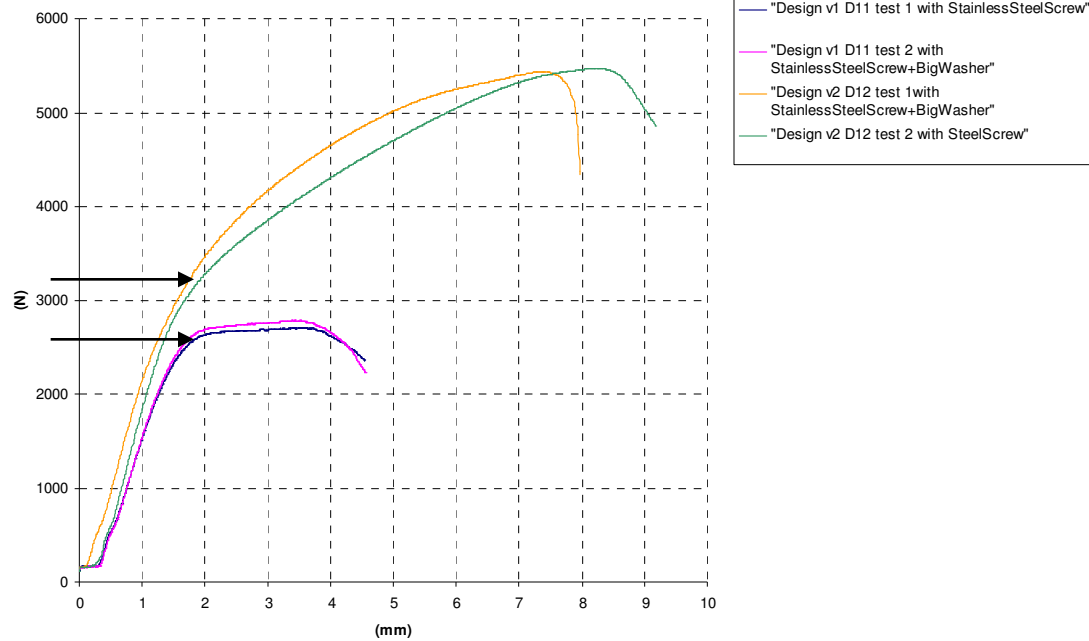
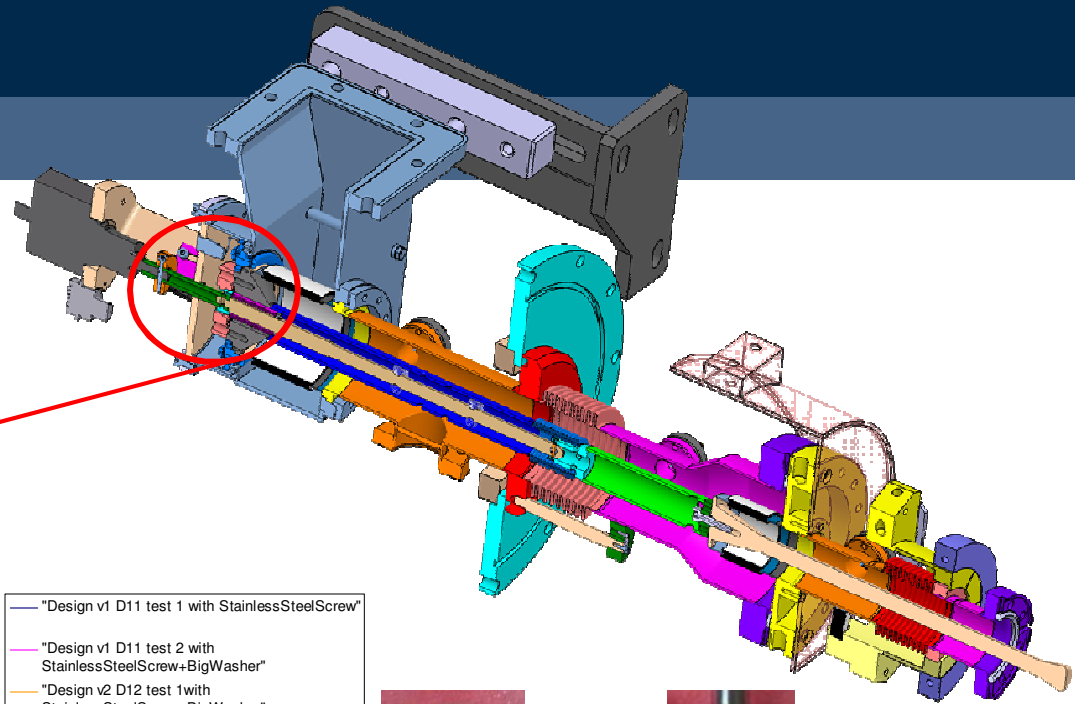
XFEL design

ILC HiGrade WP7 couplers

Design example

Insulator axle (+/- 800N)

■ Pull tests

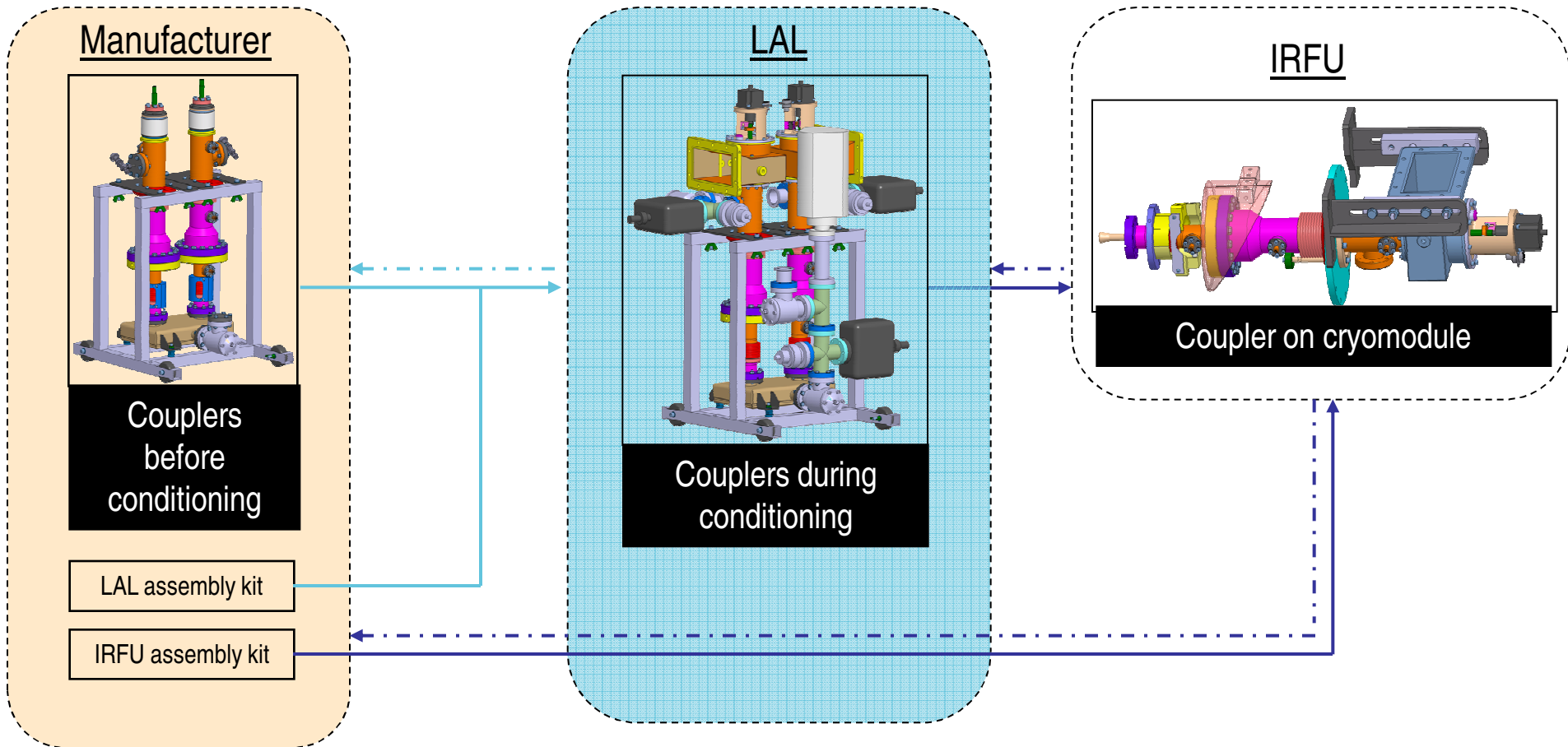


Summary

- ILC HiGrade base line strategy
- XFEL Coupler Design
- XFEL Coupler production
 - Sub-contractor: Fabrication/Cleaning & pre-assembly
 - LAL: Baking/Conditioning/Disassembly
- ILC Higrade schedule scenarios
- ILC Higrade cost scenarios

ILC HiGrade WP7 couplers

XFEL Coupler production

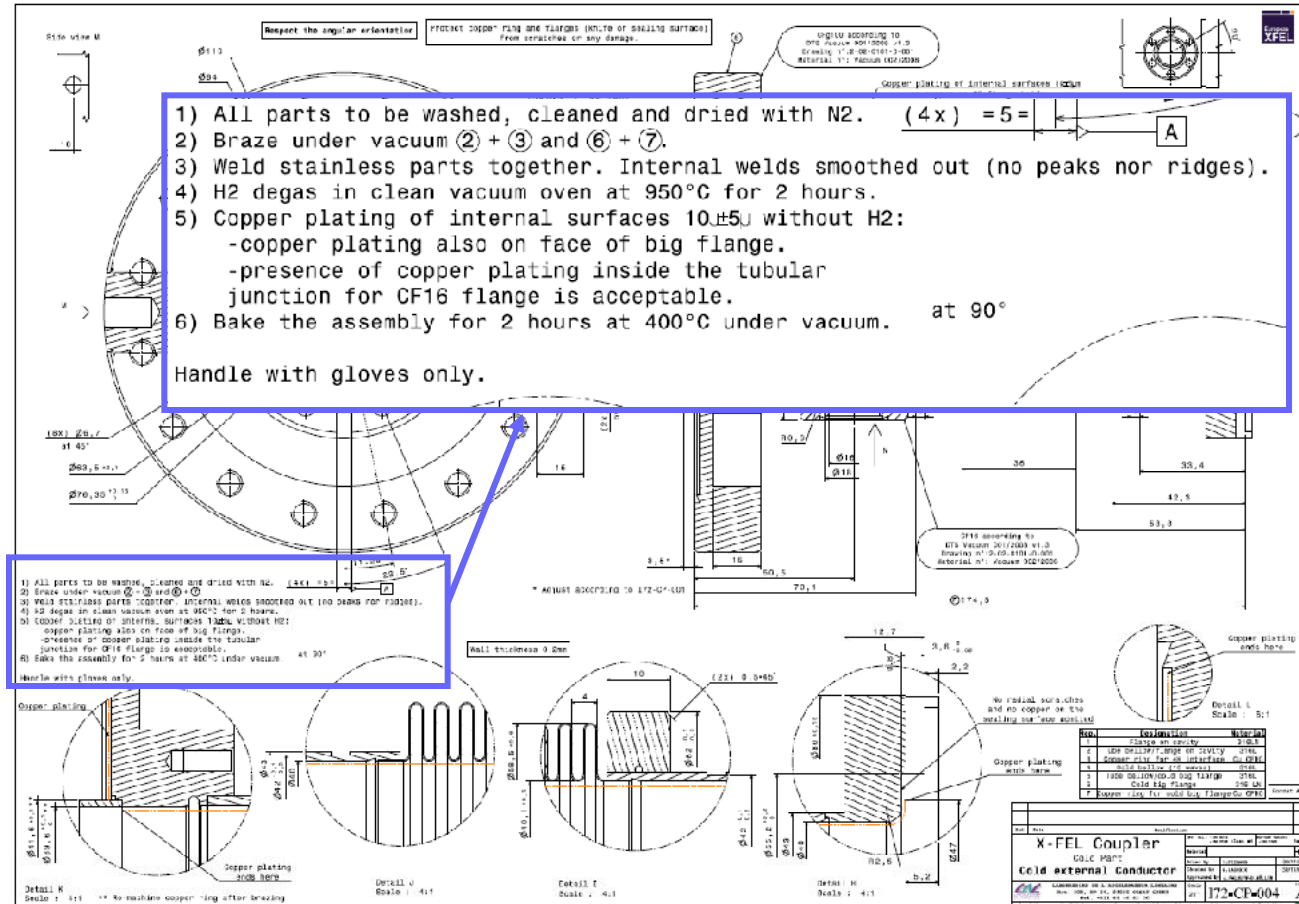


Summary

- ILC HiGrade base line strategy
- XFEL Coupler Design
- XFEL Coupler production
 - Sub-contractor: Fabrication/Cleaning & pre-assembly
 - LAL: Baking/Conditioning/Disassembly
- ILC Higrade schedule scenarios
- ILC Higrade cost scenarios

Process

- Mainly the same than TTF3

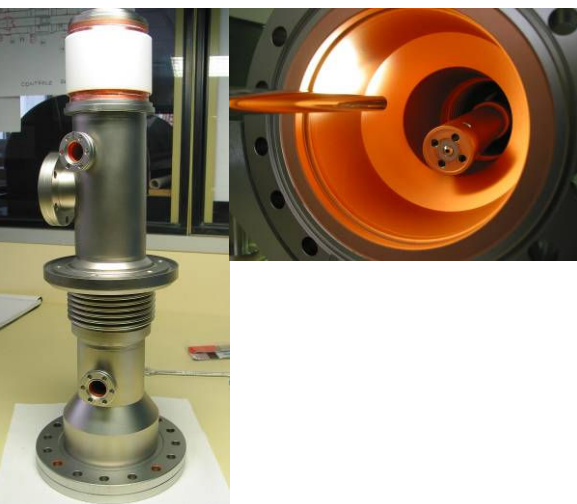


Fabrication

Process

- Mainly the same than TTF3
- But with focuses on critical aspects

J38		CP3H43		CP3H44		CP3H45		CP3H46		CP3H47	
1	B	O	D	E	F	G	H	I			
2	Delivery date		23/11/2007	23/11/2007		23/11/2007		24/11/2007		24/11/2007	
3	Inspector		Alice Mano Yann	Alice Mano Yann		Alice Mano Yann		Alice Mano Yann		Alice Mano Yann	
4	PMS		05/11/2007	05/11/2007		05/11/2007		05/11/2007		11/12/2007	
5	Select		All	All		All		All		All	
6	Magnification		date	date		date		date		date	
7	1	Scratches, finger knife edge damage, abrasion	OK	OK	OK	unknown material on small area of the knife	zamo copper on the knife + dust/fibber	OK	OK	OK	OK
8	2	Edge profile, knife/sawtooth	OK	OK	OK	OK	OK	OK	OK	OK	OK
9	3	Copper Stress corrosion mark location	large stress mark	OK	OK	OK	OK	OK	OK	OK	OK
10	4	Welds: Form, irregularities, overallity of welding quality	Copper flame zoom to be bigger	OK	OK	Copper flame zoom to be bigger but centered	slightly uncentered	OK	OK	OK	OK
11	5	Brushed: form, overallity, metallographic borderlines, abrasion, fibers	OK	OK	OK	OK	OK	OK	OK	OK	OK
12	6	Transverse ceramic: form, abrasion, irregularities, overallity of ceramic, Brass build-up	high mark	OK	OK	OK	OK	OK	OK	OK	OK
13	7	Welds: Form, irregularities, overallity of welding quality	OK	OK	OK	OK	OK	OK	OK	OK	OK
14	8	Welds: Form, irregularities, overallity of welding quality	Scratch mark + slight oxide	OK	OK	OK	OK	OK	OK	OK	OK
15	9	Form of the welds	Spot of brass material	OK	OK	OK	OK	OK	OK	OK	OK
16	10	Scratches, knife edge damage, abrasion	OK	OK	OK	OK	OK	OK	OK	OK	OK
17	11	Scratches, knife edge damage, abrasion	OK	OK	OK	OK	OK	OK	OK	OK	OK
18	12	Brush type of which is used off	OK	OK	OK	OK	OK	OK	OK	OK	OK
19	13	Condition of the welding surface	OK	OK	OK	OK	OK	OK	OK	OK	OK
20	14	Bush: shape, blank fibers, welding residues	Spot	OK	OK	OK	OK	OK	OK	OK	OK
21	15	Scratches, ridge damage, abrasion	OK	OK	OK	OK	OK	OK	OK	OK	OK
22	16	Surface of joint: scratches, ridge damage, abrasion	OK	OK	OK	OK	OK	OK	OK	OK	OK
23	17	Control of ridge	OK	OK	OK	OK	OK	OK	OK	OK	OK
24	18	Other	OK	OK	OK	OK	OK	OK	OK	OK	OK
25	19	Internal surface of ceramic: irregularities, fibers, abrasion	OK	OK	OK	OK	OK	OK	OK	OK	OK
26	20	Welds: Form, irregularities, overallity of welding quality	OK	OK	OK	OK	OK	OK	OK	OK	OK
27	21	Form of the internal ridge: DMS	OK	OK	OK	OK	OK	OK	OK	OK	OK
28	22	Form of the internal ridge: DMS	OK	OK	OK	OK	OK	OK	OK	OK	OK
29	23	Form of the internal ridge: DMS	OK	OK	OK	OK	OK	OK	OK	OK	OK
30	24	Form of the internal ridge: DMS	OK	OK	OK	OK	OK	OK	OK	OK	OK
31	25	Form of the internal ridge: DMS	OK	OK	OK	OK	OK	OK	OK	OK	OK
32	26	Form of the internal ridge: DMS	OK	OK	OK	OK	OK	OK	OK	OK	OK
33	27	Form of the internal ridge: DMS	OK	OK	OK	OK	OK	OK	OK	OK	OK
34	28	Form of the internal ridge: DMS	OK	OK	OK	OK	OK	OK	OK	OK	OK
35	29	Form of the internal ridge: DMS	OK	OK	OK	OK	OK	OK	OK	OK	OK
36	30	Form of the internal ridge: DMS	OK	OK	OK	OK	OK	OK	OK	OK	OK
37	31	Form of the internal ridge: DMS	OK	OK	OK	OK	OK	OK	OK	OK	OK
38	32	Form of the internal ridge: DMS	OK	OK	OK	OK	OK	OK	OK	OK	OK
39	33	Form of the internal ridge: DMS	OK	OK	OK	OK	OK	OK	OK	OK	OK
40	34	Form of the internal ridge: DMS	OK	OK	OK	OK	OK	OK	OK	OK	OK
41	35	Form of the internal ridge: DMS	OK	OK	OK	OK	OK	OK	OK	OK	OK
42	36	Form of the internal ridge: DMS	OK	OK	OK	OK	OK	OK	OK	OK	OK
43	37	Form of the internal ridge: DMS	OK	OK	OK	OK	OK	OK	OK	OK	OK
44	38	Form of the internal ridge: DMS	OK	OK	OK	OK	OK	OK	OK	OK	OK

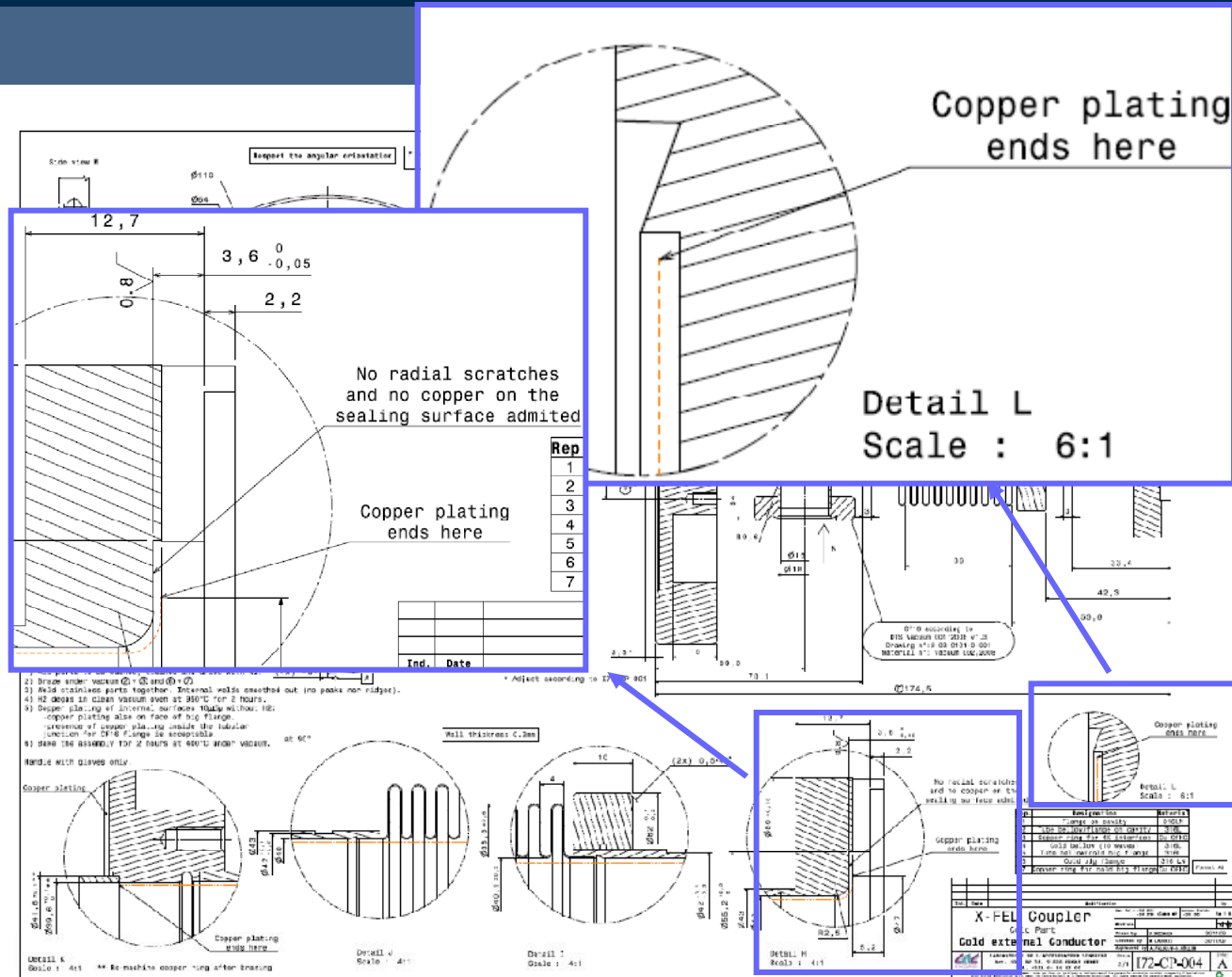


ILC HiGrade WP7 couplers

Fabrication

Process

- Mainly the same than TTF3
- But with focuses on critical aspects



ILC HiGrade WP7 couplers

Cleaning & pre-assembly

- Class 10 clean room
- US bath cleaning with detergent at 50°C
- Drying with filtered N2 and under laminar flux
- Particle count
- Leak test



Légende	N°	Nom de l'étape
classe 1000	0	Fabrication
classe 10	2	Préparation des kits d'assemblage
Flux laminaire classe 100	3	Lavage des 2 parties froides + transition froide + châssis
Hall		Cycle de séchage
	4	Comptage particules/pré assemblage parties froides/étuvage
	5	Assemblage partie froide + Test + Montage
	6	Lavage des 2 parties froides
	7	Pré assemblage + Étuvage
	8	Mise en place de la partie froide + Test + Étuvage
	9	Mise en place de la partie chaude d'étuvage
	9'	Protection des céramiques
	9''	Emballage en
	9'''	Expédition

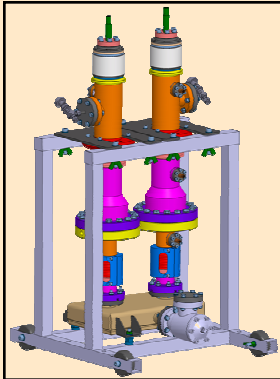
Stage 4	Particle count / pre-assembly of cold parts
	ISO4
	Preparation
	Make sure that the N2 bottle, which is outside of the clean room, is open and under pressure of 4 bar.
	Necessary material
	All parts from the previous stage
	Tasks
	Write down the reference of the mounting
	<u>Visual inspection:</u> ↳ Do the visual inspection of all cleaned parts
	<u>Particle count in cold parts:</u> ↳ Blow on the cold parts with filtered ionized nitrogen as shown in picture here on the right ↳ Launch the recording of the particle count ↳ Measure for 1 min, if fewer than 10 particles of size under 0.3µm, controlled part considered clean. If result not achieved, restart the count until result reached ↳ If over 9 cycles of 1 min are not giving the aforementioned results, the part is considered not clean and has to be re-cleaned in the ultrasonic bath. ↳ Execute the previous tasks on the positions shown in pictures here below:
	Print the count ticket. ↳ Execute all these tasks on the second cold part.
	<u>Particle count on the transition cavity:</u> ↳ Place the threaded rods on the transition cavity while the blind flanges are on Attention: The operator must be standing opposite from the pumping flange ↳ Execute the particle count according to the aforementioned cycle in both positions shown in pictures here below

Paire / pair n°		S2P1	
Composition de la paire/composition on test stand			
	Upstream1	Downstream 2	
Warm transitions	CP3W43	CP3W44	
Condensator	43	44	
Warm parts	CP3H43	CP3H44	
Cold parts	CP3C57	CP3C58	
Test stand	TWG13		
Remarks			
Nettoyage et assemblage parties froides/Cleaning and assembling of Cold parts			
Opérations classe 1000 / Class 1000 operations			
	22/10/08 0:00	Date	
Ultrasonic bath	50 °C	5	15 Tps min
Resistivity of rinsing water	>14 M.Ohm/cm	1. Ficheuse RSP	
Remarks			
Opérations classe 10 / Class 10 operations			
	28/10/08 0:00	Date	
Drying time	144	Heures	
Particle control	OK		
Baking in oven	150 °C	2 hours	

ILC HiGrade WP7 couplers

XFEL Coupler production

Manufacturer



Couplers
before
conditioning

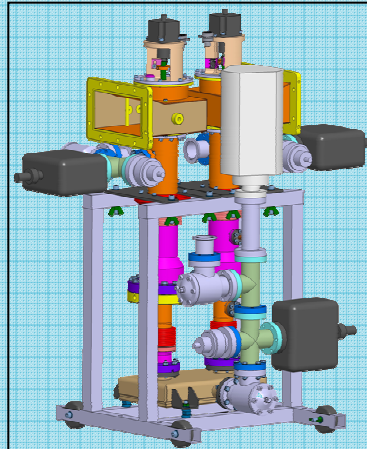
LAL assembly kit

IRFU assembly kit

Call for tender (March)

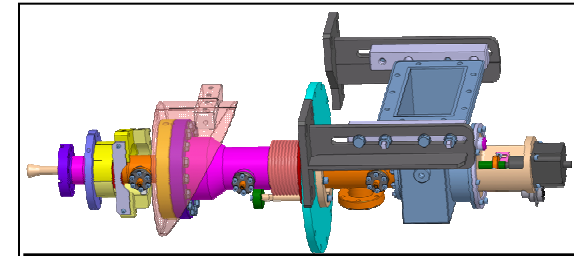
Notifications (June)

LAL



Couplers during
conditioning

IRFU



Coupler on cryomodule

First couplers of the
Pre-series (1x12)

2010

2011

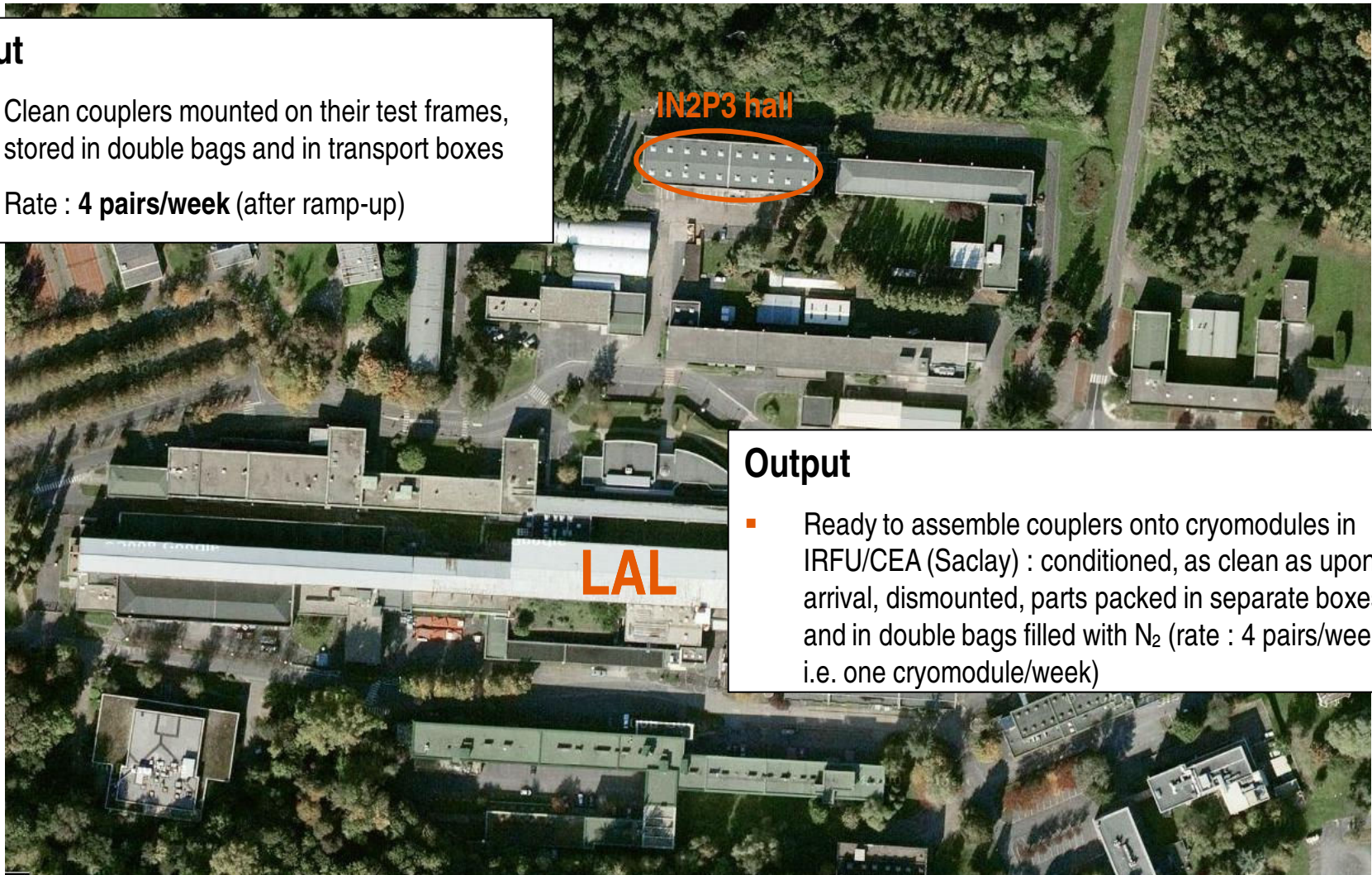
Summary

- ILC HiGrade base line strategy
- XFEL Coupler Design
- XFEL Coupler production
 - Sub-contractor: Fabrication/Cleaning & pre-assembly
 - LAL: Baking/Conditioning/Disassembly
- ILC Higrade schedule scenarios
- ILC Higrade cost scenarios

Localization

Input

- Clean couplers mounted on their test frames, stored in double bags and in transport boxes
- Rate : **4 pairs/week** (after ramp-up)



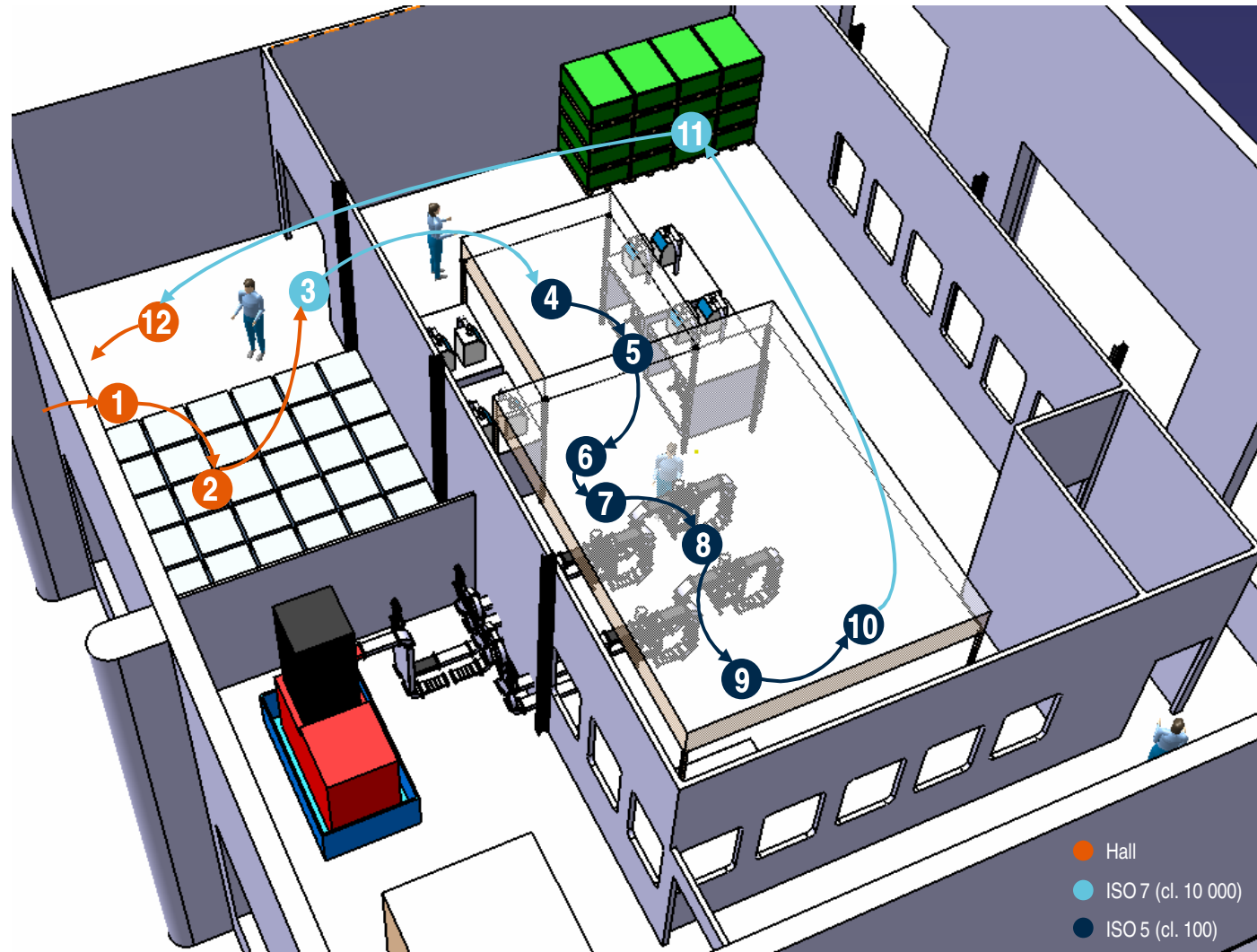
Output

- Ready to assemble couplers onto cryomodules in IRFU/CEA (Saclay) : conditioned, as clean as upon arrival, dismantled, parts packed in separate boxes and in double bags filled with N_2 (rate : 4 pairs/week, i.e. one cryomodule/week)

ILC HiGrade WP7 couplers

Process and infrastructure layout at LAL

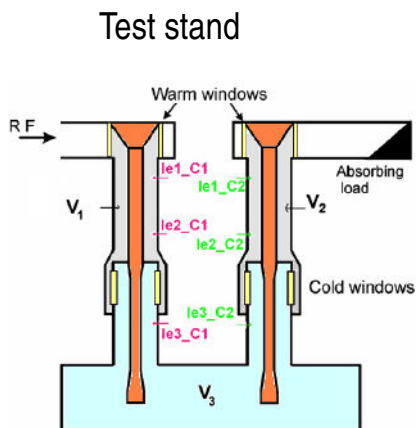
- 1 Reception
- 2 Storage
- 3 Unpacking (box)
- 4 Unpacking (bag)
- 5 In situ baking
- 6 Ionic pumping
- 7 Antenna adjustment
- 8 Conditioning
- 9 Dismounting
- 10 Packaging
- 11 Storage
- 12 Expedition



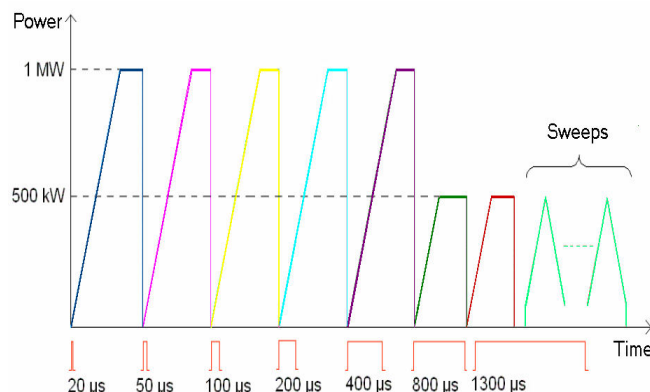
- Hall
- ISO 7 (cl. 10 000)
- ISO 5 (cl. 100)

E. Genesseau et al

RT conditioning @LAL : traveling wave



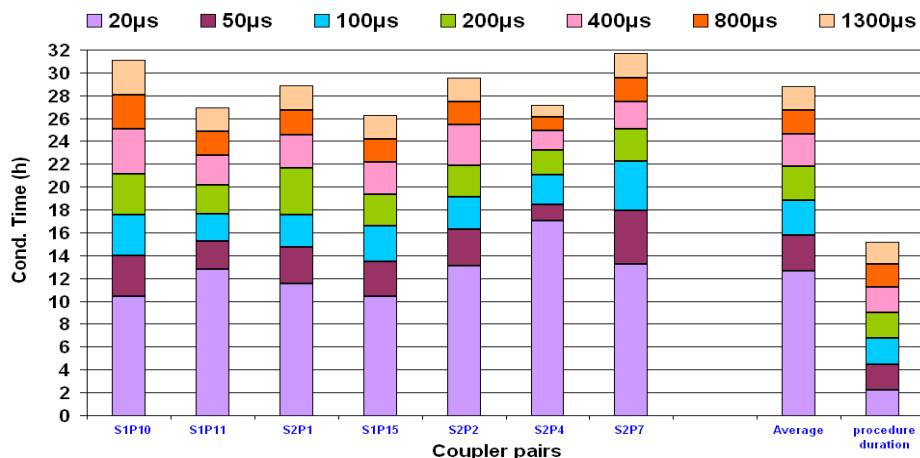
Procedure



XFEL parameters

		Original parameters	Optimised parameters
Vacuum	1st threshold (↓ 0.1 dB)	$2 \cdot 10^{-7}$ mbar	$6 \cdot 10^{-7}$ mbar
	2nd threshold (↓ 0.4 dB)	$4 \cdot 10^{-7}$ mbar	10^{-6} mbar
	IL	10^{-6} mbar	$5 \cdot 10^{-6}$ mbar
e- current IL		5 mA	
Light IL		1 lux	none
Ceramic temperature IL		85 C	
WG arc IL		if any	
Repetition rate		2 Hz	4 Hz
Control loop duration ↑ 0.1 dB		30 s	15 s

Last conditioning tests

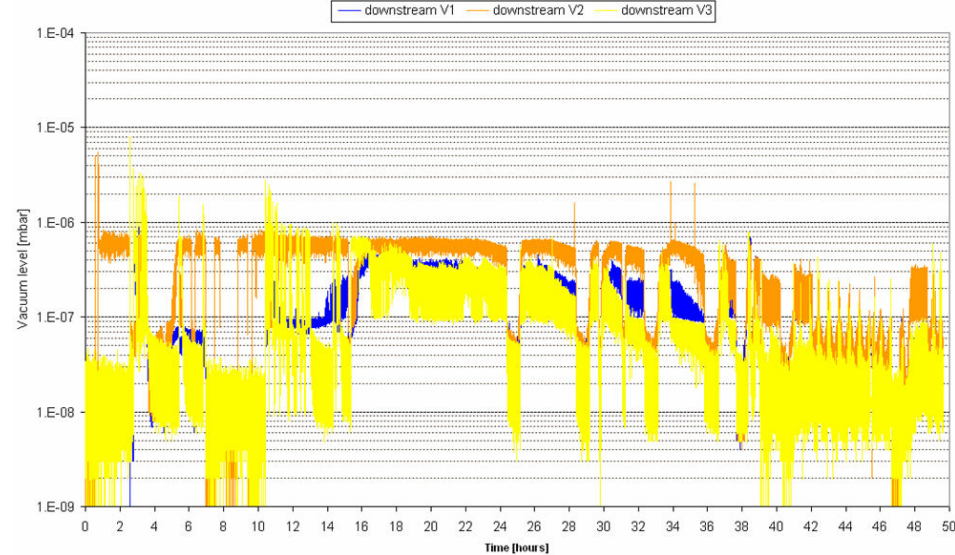
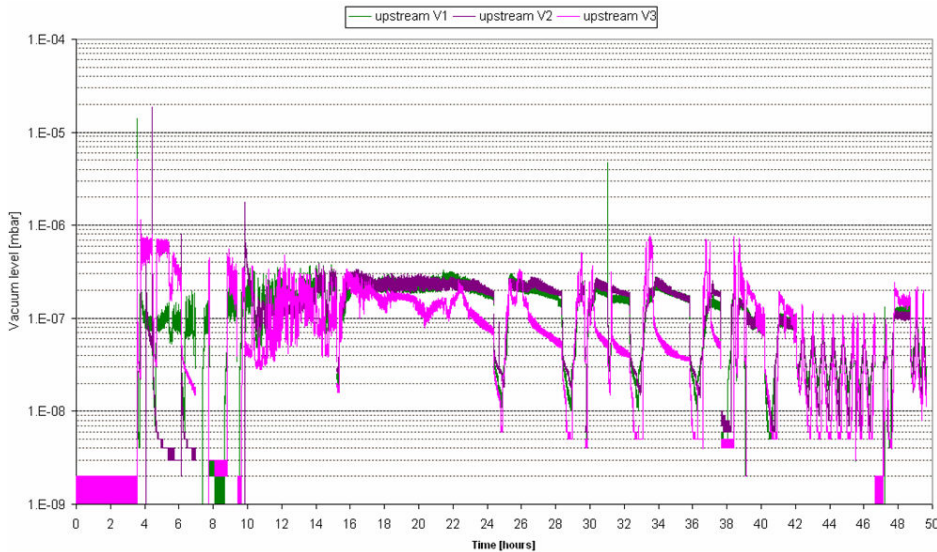
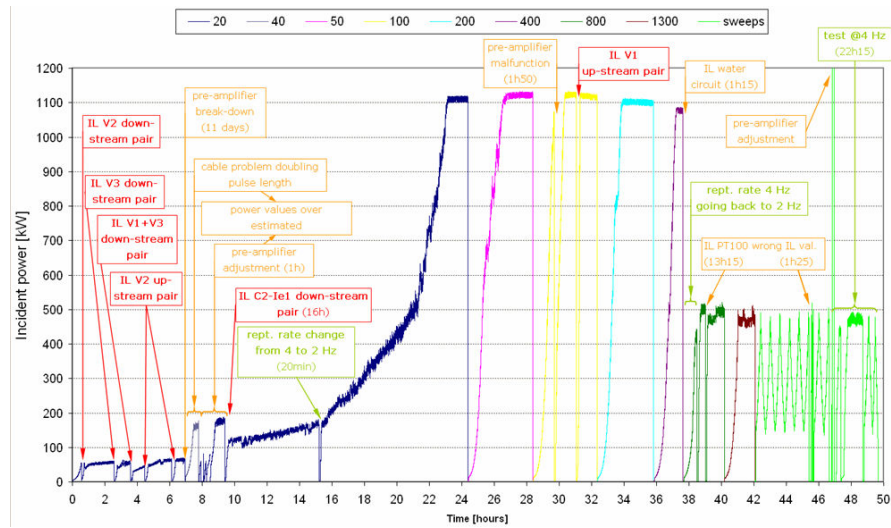


Conditioning steps	RF Power (kW)	Max. tolerated time to achieve a power level or a step (h)
20μs	0 → 100	6
	0 → 200	9.5
	0 → 300	11.5
	0 → 400	13
	0 → 500	15
	0 → 600	17
	0 → 700	19
	0 → 800	21
	0 → 900	23
	0 → max	$T_{\max 20\mu s} = 25$
50μs	0 → max	$T_{\max 20\mu s} + 2.5 = 27.5$
100μs	0 → max	$T_{\max 20\mu s} + 2.5 + 3.5 = 31$
200μs	0 → max	$T_{\max 20\mu s} + 2.5 + 3.5 + 3 = 34$
400μs	0 → max	$T_{\max 20\mu s} + 2.5 + 3.5 + 3 + 3 = 37$
800μs	0 → max	$T_{\max 20\mu s} + 2.5 + 3.5 + 3 + 3 + 2 = 39$
1300μs	0 → max	$T_{\max 20\mu s} + 2.5 + 3.5 + 3 + 3 + 2 + 5 = 44$

H. Jenhani et al., NIM A 595 (2008)

ILC HiGrade WP7 couplers

Conditioning of 2 pairs of TTF3 couplers in series



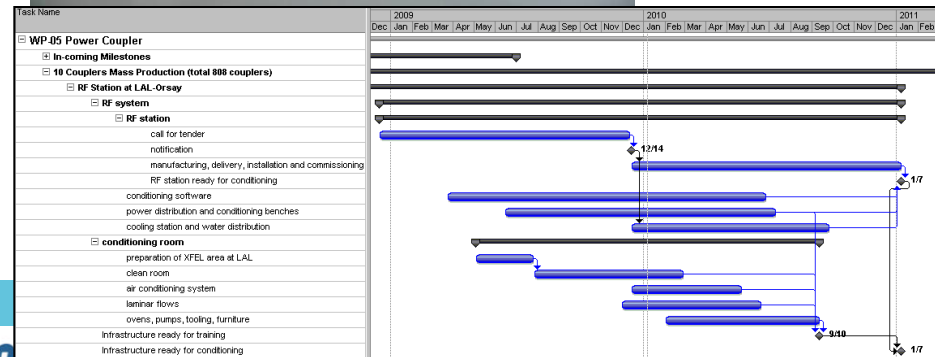
L. Lukovac et al

ILC HiGrade WP7 couplers

Infrastructure → Current situation

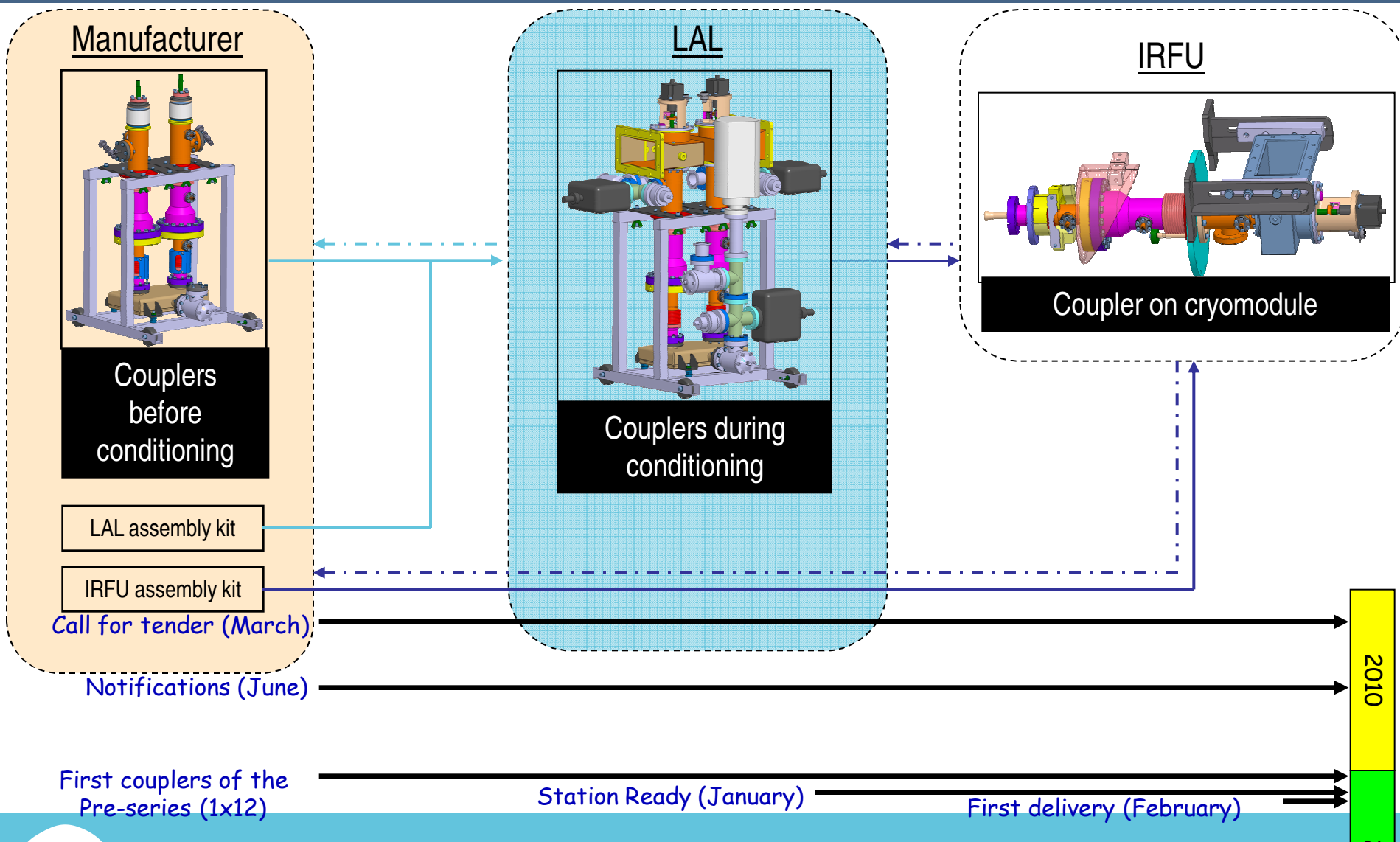


Station ready by January 2011



ILC HiGrade WP7 couplers

XFEL Coupler production



Summary

- ILC HiGrade base line strategy
- XFEL Coupler Design
- XFEL Coupler production
 - Sub-contractor: Fabrication/Cleaning & pre-assembly
 - LAL: Baking/Conditioning/Disassembly
- ILC Higrade schedule scenarios
- ILC Higrade cost scenarios

Scenario 1

- LAL First Coupler delivery date < IRFU First cryomodule assembly date
- In that case, all the first couplers can be delivered to ILC HiGrade

Scenario 2

- LAL First Coupler delivery date > or = IRFU First cryomodule assembly date
- Flow of coupler delivery > Flow of coupler needed at IRFU
- In that case, a pourcentage of the couplers can be delivered to ILC HiGrade along the production **but the ILC HiGrade schedule may be delayed**

Scenario 3

- LAL First Coupler delivery date > or = IRFU First cryomodule assembly date
- Flow of coupler delivery < Flow of coupler needed at IRFU
- In that case, ILC HiGrade have to wait the end of XFEL production, **the ILC HiGrade schedule will be delayed**

Summary

- ILC HiGrade base line strategy
- XFEL Coupler Design
- XFEL Coupler production
 - Sub-contractor: Fabrication/Cleaning & pre-assembly
 - LAL: Baking/Conditioning/Disassembly
- ILC Higrade schedule scenarios
- ILC Higrade cost scenarios

Scenario 1

- Cost of 30 XFEL couplers < ILC HiGrade Budget
- 30 couplers will be ordered, everybody is very happy!!!!

Scenario 2

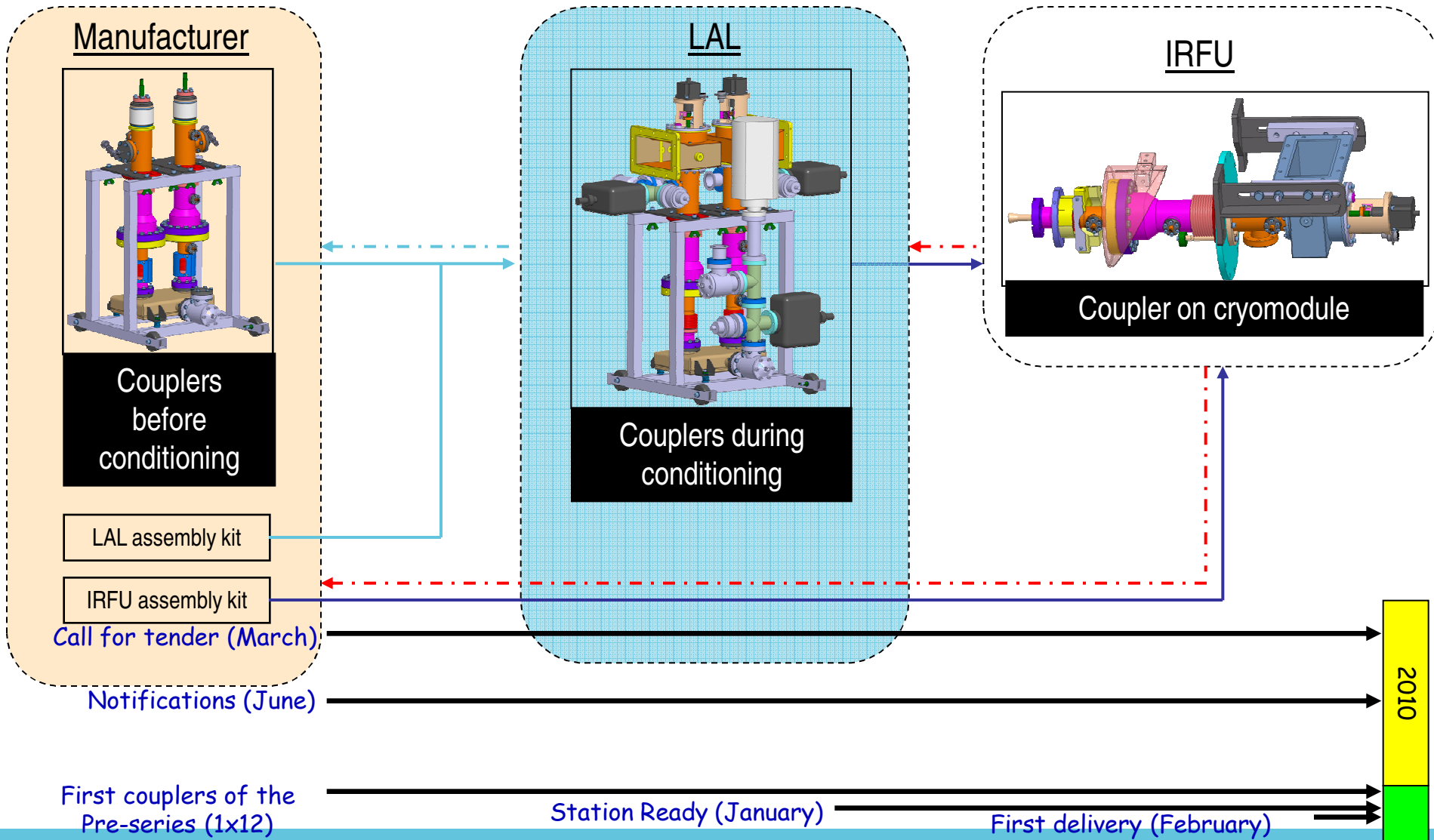
- Cost of 30 XFEL couplers > ILC HiGrade Budget > Cost of 24 XFEL couplers
- « n » couplers will be ordered ($24 < n < 30$), everybody is happy!

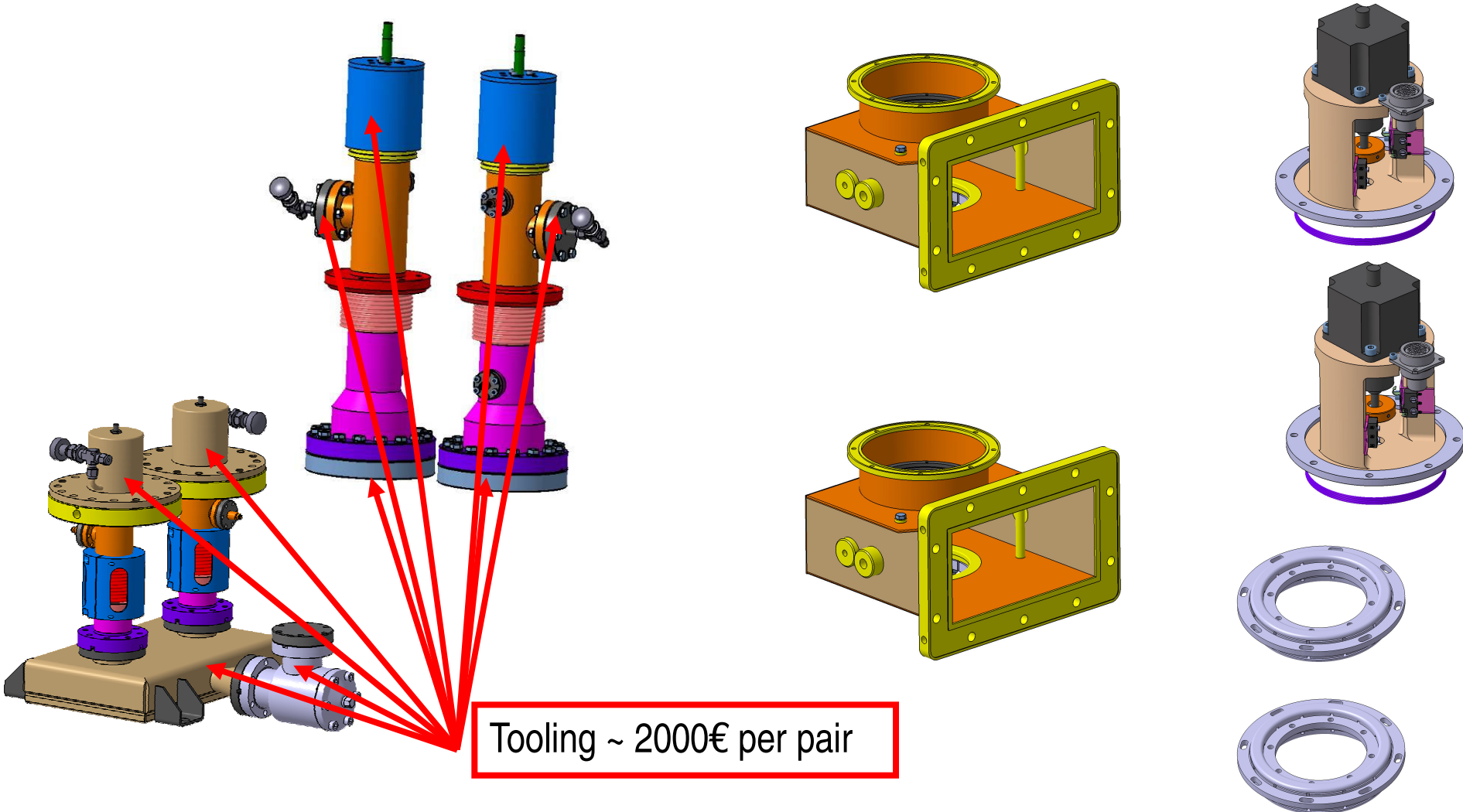
Scenario 3

- Cost of 24 XFEL couplers > ILC HiGrade Budget
- « n » couplers will be ordered ($n < 24$), everybody is looking for an **additional budget!!!!**

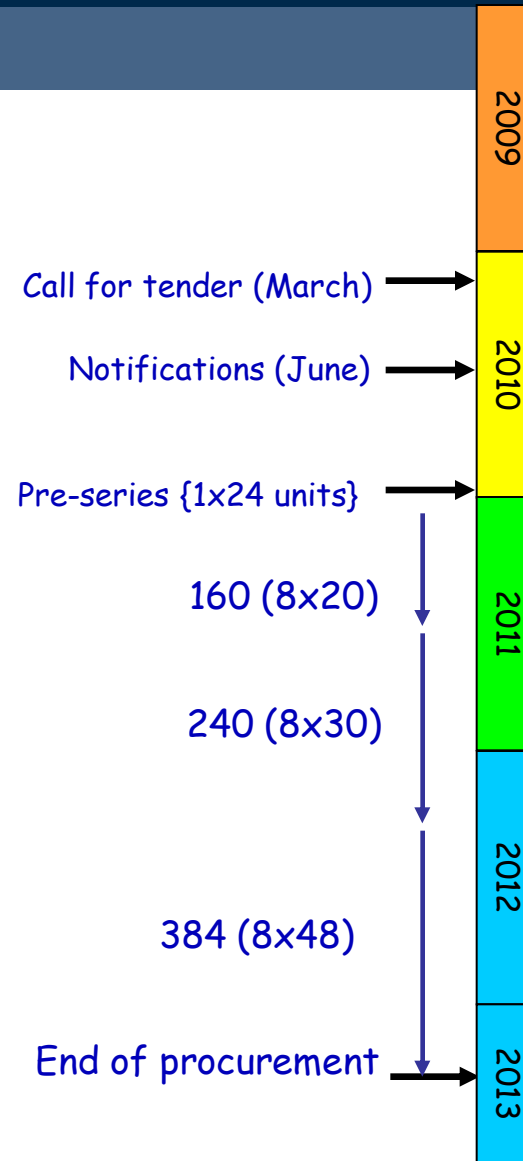
ILC HiGrade WP7 couplers

XFEL Coupler production



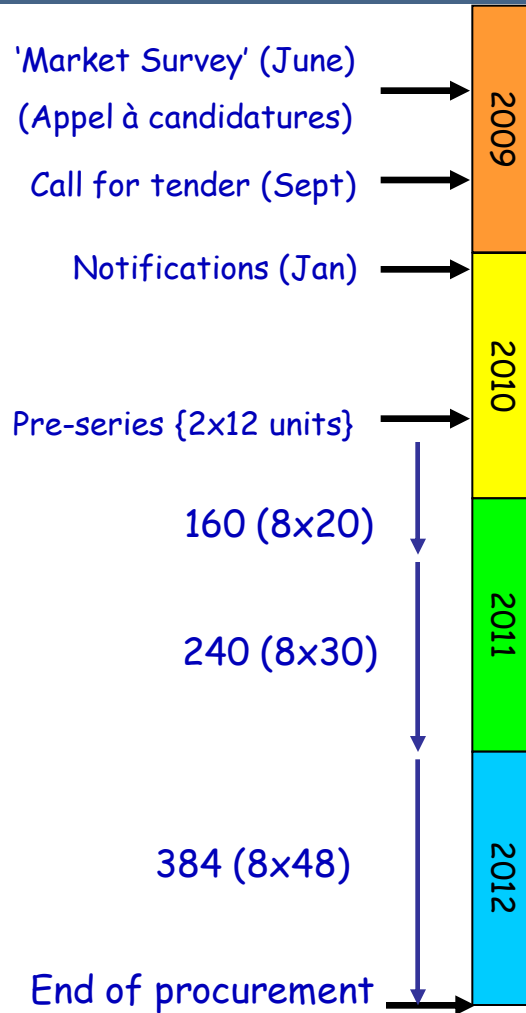


XFEL Schedule



ILC HiGrade WP7 couplers

XFEL Schedule



Delay of 6 months

